# Electronic Version v1.1 Stylesheet Version v1.1

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

## **CONVEYING PARTY DATA**

Name	Execution Date
Jin-Ku LEE	06/26/2008
Jae-Geun OH	06/26/2008
Sun-Hwan HWANG	06/26/2008

### **RECEIVING PARTY DATA**

Name:	Hynix Semiconductor Inc.	
Street Address:	San 136-1, Ami-ri, Bubal-eub	
City:	Ichon-shi, Kyoungki-do	
State/Country:	REPUBLIC OF KOREA	
Postal Code:	467-860	

#### PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	12165182

#### **CORRESPONDENCE DATA**

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ATTORNEY DOCKET NUMBER: 00939H-172600US

NAME OF SUBMITTER: Evelyn D. Jackson

Total Attachments: 2

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PATENT REEL: 021214 FRAME: 0952

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PATENT REEL: 021214 FRAME: 0953

Attorney Docket No.	
Client Ref. No.	

#### ASSIGNMENT OF PATENT APPLICATION

WHEREAS, <u>LEE, Jin-Ku and OH, Jae-Geun; and HWANG, Sun-Hwan</u> of San 136-1, Ami-ri, Bubal-eub, Ichon-shi, Kyoungki-do 467-860, Republic of Korea,		
hereinafter referred to as "Assignor," is the inventor of the invention described and set forth in the below		
-identified application for United States Letters Patent:		
Title of Invention: METHOD FOR DOPING POLYSILICON AND METHOD FOR		
FABRICATING A DUAL POLY GATE USING THE SAME		
Date(s) of execution of Declaration:		
Filing Date:		
Application No.: 12/165,182; and		

WHEREAS, Hynix Semiconductor Inc. of San 136-1, Ami-ri, Bubal-eub, Ichon-shi, Kyoungki-do 467-860, Republic of Korea hereinafter referred to as "ASSIGNEE," is desirous of acquiring an interest in the invention and application and in any U.S.

Letters Patent and Registrations which may be granted on the same;

For good and valuable consideration, receipt of which is hereby acknowledged by Assignor, Assignor has assigned, and by these presents does assign to Assignee all right, title and interest in and to the invention and application and to all foreign counterparts (including patent, utility model and industrial designs), and in and to any Letters Patent and Registrations which may hereafter be granted on any patent application claiming priority from the same in the United States and all countries throughout the world, and to claim the priority from the application as provided by the Paris Convention. The right, title and interest is to be held and enjoyed by Assignee and Assignee's successors and assigns as fully and exclusively as it would have been held and enjoyed by Assignor had this Assignment not been made, for the full term of any Letters Patent and Registrations which may be granted thereon, or of any division, renewal, continuation in whole or in part, substitution, conversion, reissue, prolongation or extension thereof.

Assignor further agrees that Assignor will, without charge to Assignee, but at Assignee's expense, (a) cooperate with Assignee in the prosecution of U.S. Patent applications and foreign counterparts on the invention and any improvements, (b) execute, verify, acknowledge and deliver all such further papers, including applications and instruments of transfer, and (c) perform such other acts as Assignee lawfully may request to obtain or maintain Letters Patent and Registrations for the invention and improvements in any and all countries, and to vest title thereto in Assignee, or Assignee's successors and assigns.

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PATENT REEL: 021214 FRAME: 0954

Attorney Docket No.	
Client Ref. No	

Assignor hereby authorizes and requests Townsend and Townsend and Crew LLP, Two Embarcadero Center, 8<sup>th</sup> Floor, San Francisco, CA 94111-3834, to insert herein above the application number and filing date of said application when known.

IN TESTIMONY WHEREOF, Assignor has signed his/her name on the date indicated.

Dated: June 26, 2008

LEE, J'M-KU LEE, Jin-Ku

Dated: June 26, 2008

OH, JAEGELIN

OH, Jae-Geun

Dated: June 26, 2008

HWANIG, Sun-Hwan

HWANG, Sun-Hwan

WITNESSED BY:

Name: PARK, Sang-Mi

Address: ID Tower #601, Jungdaero 105 (99-7 Garak-dong)Songpa-gu, Seoul 138-805,

Republic of Korea

Date: June 26, 2008

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**RECORDED: 07/09/2008**